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(54) ELECTROMAGNETIC WAVE SHIELD MEMBER WITH NEGATIVE ION EFFECT

(57)Abstract:

PROBLEM TO BE SOLVED: To provide an electromagnetic wave shield member that can be manufactured by a simple method and at a comparatively low cost, and by which a high shield effect can be obtained and a negative effect be also expected.

SOLUTION: An electromagnetic wave shield member is formed by providing a metallic plating layer on the surface of a molding made of organic polymer material (ABS or the like) mixed with a powder having a negative ion generating function. The metallic plating layer is preferably formed by applying electric plating on electroless-plated layer, and an electric plating liquid is mixed with the powder for generating the anion, thus realizing a product with higher negative ion and electromagnetic wave shield effects.

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